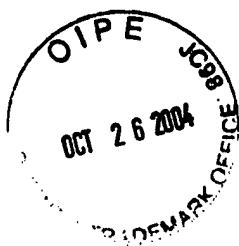




*Rfw*

<b>AMENDMENT TRANSMITTAL LETTER</b>			Docket No. M4065.0319/P319		
Application No. 09/296,835		Filing Date April 22, 1999	Examiner Erik Kielin	Art Unit 2813	
Applicant(s): Ronald A. Weimer, et al.					
Invention: METHOD OF FABRICATING A SEMICONDUCTOR DEVICE WITH A DIELECTRIC FILM USING A WET OXIDATION WITH STEAM PROCESS (AS AMENDED)					
<b>TO THE COMMISSIONER FOR PATENTS</b>					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
<b>CLAIMS AS AMENDED</b>					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	9	- 40 =		x	0.00
Independent Claims	3	- 8 =		x	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					
<input checked="" type="checkbox"/> Large Entity <span style="margin-left: 200px;"><input type="checkbox"/> Small Entity</span>					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Commissioner is hereby authorized to charge and credit Deposit Account No. <u>04-1073</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
<div style="text-align:right"> _____ Thomas J. D'Amico Attorney Reg. No.: 28,371 DICKSTEIN SHAPIRO MORIN &amp; OSHINSKY LLP 2101 L Street NW Washington, DC 20037-1526 (202) 828-2232</div>			Dated: <u>October 26, 2004</u>		



Docket No.: M4065.0319/P319  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Ronald A. Weimer, et al.

Examiner: Erik Kielin

Application No.: 09/296,835

Art Unit: 2813

Filed: April 22, 1999

For: METHOD OF FABRICATING A  
SEMICONDUCTOR DEVICE WITH A  
DIELECTRIC FILM USING A WET  
OXIDATION WITH STEAM PROCESS (AS  
AMENDED)

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

Commissioner for Patents  
MS: Amendment  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This paper is in response to the Office Action dated July 29, 2004. Please amend the above-identified U.S. patent application as follows:

**An Amendment to the Specification** is listed on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks** begin on page 7 of this paper.